

FORM PTO 1449 (modified)

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APPLICANT
Shinsuke YAMANAKA et al.

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GROUP

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
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	AG						

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		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
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/A.S./	AI	0832847 A1	04/1998	EP			
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/A.S./	AP	Hideaki MASUDA et al., "The Fabrication of Porous TiO ₂ Films Using Two-Step Replication of Microstructure of Anodic Alumina", <i>Jpn. J. Appl. Phys.</i> Vol. 31 (1992) pp. L1775-L1777 Part 2, No. 12B, 15 December 1992.
/A.S./	AQ	Takashi SUGIURA et al., "The control of a minute structure of TiO ₂ surface by a photoelectrochemical etching", 18 th Discussion about Solid and Surface Photochemistry, November 1999.

EXAMINER /AITrev Sykes/

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